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REVOCATION OF PATENT APPLICATION

DATE: January 12, 2004

TO: The Patent Examiner, United States Patent and
Trademark Office

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RE: Cancellation of Patent Application/Control
Number: **10/081,016**
Applicants: WANG ET AL.
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Art Unit: 1762
Process for Plasma Sulfurization in Vacuum

The applicants of the above referenced patent application hereby expressly abandon all claims related to the patent, in its entirety. Please revoke all claims and withdraw the application in the present case from public record.

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